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SERIAL NUMBER 10/660,813	FILING DATE 09/12/2003 RULE	CLASS 204	GROUP ART UNIT 1753	ATTORNEY DOCKET NO. A8067/T51700
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** CONTINUING DATA ****

This application is a CIP of 10/279,961 10/23/2002 PAT 6,802,944 *Jm*

** FOREIGN APPLICATIONS ****

none n

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 12/03/2003

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	CA	DRAWING 12	28	3
Verified and Acknowledged	<i>Examiner's Signature</i>	<i>Initials</i>			

ADDRESS

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TITLE

Reactive ion etching for semiconductor device feature topography modification

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)
<input type="checkbox"/> 1.17 Fees (Processing Ext. of

FILING FEE FEES: Authority has been given in Paper

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